

PATURE /03 8733.085.00

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re application of

Hyun Chang LEE, et al.

Group Art Unit: 2675

Application No.: 09/353,842

Examiner: ANYASO, Uchendu O.

Filed: July 15, 1999

Confirmation No: 4171

For:

APPARATUS AND METHOD FOR ELIMINATING A RESIDUAL

IMAGE IN A LIQUID CRYSTAL DISPLAY DEVICE

## **REQUEST FOR RECONSIDERATION**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 RECEIVED

OCT 1 7 2003

Technology Center 2600

Dear Sir:

## **INTRODUCTORY COMMENTS**

In response to the Examiner's Final Office Action dated July 14, 2003, the following remarks are respectfully submitted.

Remarks/Arguments begin on page 2 of this paper.